

AFTER FINAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Hyo-sang JUNG

Art Unit:

1762

Serial No.

10/068,005

Examiner: Marianne L. PADGETT

Filed:

February 8, 2002

Confirmation No.

6445

For:

VACUUM APPARATUS OF ION IMPLANTATION Atty. Docket No. 262/011

SYSTEM AND EVACUATION METHOD

REPLY UNDER 37 C.F.R. § 1.116

Mail Stop AF Commissioner for Patents United States Patent and Trademark Office Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action Made Final mailed June 15, 2004, the following remarks are respectfully submitted in connection with the above-identified application.

Remarks begin on page 2 of this paper.